

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>			Docket Number (Optional) BUR920040087US1	Application Number 10/709,793		
			Applicant(s) Andra, et al.	Filing Date May 28, 2004	Group Art Unit 2171	
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	REF	DOCUMENT NUMBER 	DATE	NAME	CLASS	SUBCLASS
FILING DATE IF APPROPRIATE						
U.S. PATENT APPLICATION PUBLICATIONS						
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS
FILING DATE IF APPROPRIATE						
FOREIGN PATENT DOCUMENTS						
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS
Translation						
YES NO						
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>						
MD		Meyuhas, et al., "THE OPERATIONAL LOGIC BEHIND MANAGING A FULLY AUTOMATED 300 mm FAB", Semiconductor Manufacturing, October 2003, pages 152-159				
MD		Girin, et al., "PROCESS CONTROL THROUGH LITHOGRAPHY AUTOMATION", Semiconductor Manufacturing, July 2003, pages 85-90				
EXAMINER /Mahesh Dwivedi/			DATE CONSIDERED 08/14/2006			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						